

Precision 3D Printing for Photonic Integration and Optical Coupling

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Business Development Manager

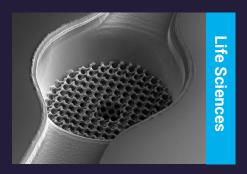
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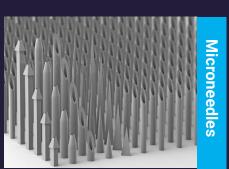
Micro Optics Summit & Expo



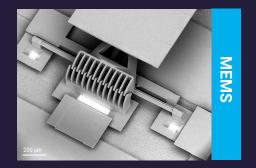
We empower cutting edgescience& industrial innovations

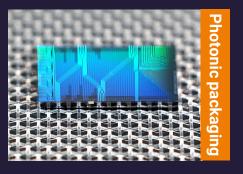


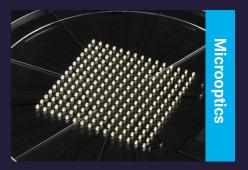














The key enabling technology

Read our Whitepapers in our premium section

- Two-Photon Polymerization (2PP)
- Two-Photon Grayscale Lithography (2GL®)
- 3) Industrial Scale-up: Mastering & Replication



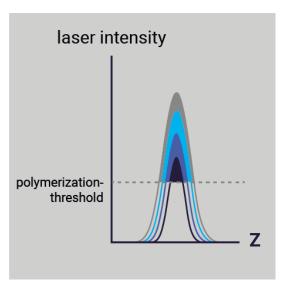


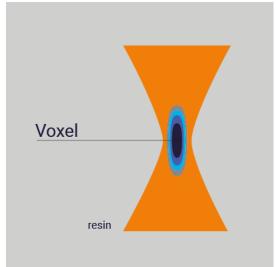


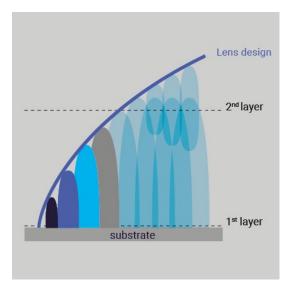
2-Photon Graysca Lithography 2GL ® *Technology

Dynamic voxel height









Free-SpaceMicrooptical Coupling (FSMOC) Efficient light coupling solutions

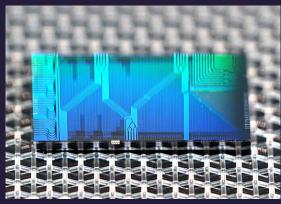


On fiber array



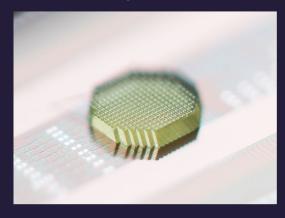
Microoptical elements on optical facet of fibers (fiber array)

On chip edge



Free-space microoptical couplers on chip edge (edge coupler)

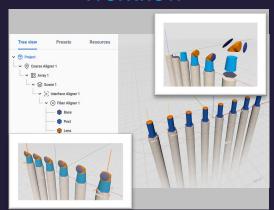
On chip surface



Free-form microlenses for vertical coupling on chip surfaces (grating coupler)

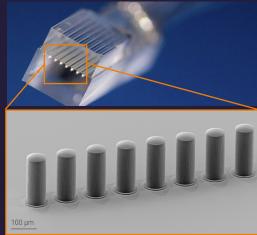
Fiber Arrays: Adapting the MFD and Numerical Aperture (National Easy print set up, flexible designs, reliable results

Workflow



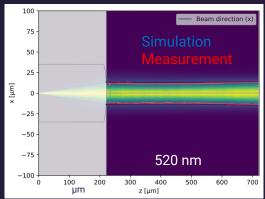
- Define lenses via formula or STL
- Align relative to fiber core
- Select process parameters
- Print & develop

Results





Characterization



Characteristic	Typ. Value
Shape accuracy	< 50 nm rms
Surface roughness R _a	< 5 nm
MFD repeatability	σ <40 nm
Loss	0.5 - 0.8 dB
Print time	10 - 80 sec / lens
Environmental (Resin)	Thermal shock -25°C to 85°C (1,000 cycles); 85° C @ 85 % rh, 1000h

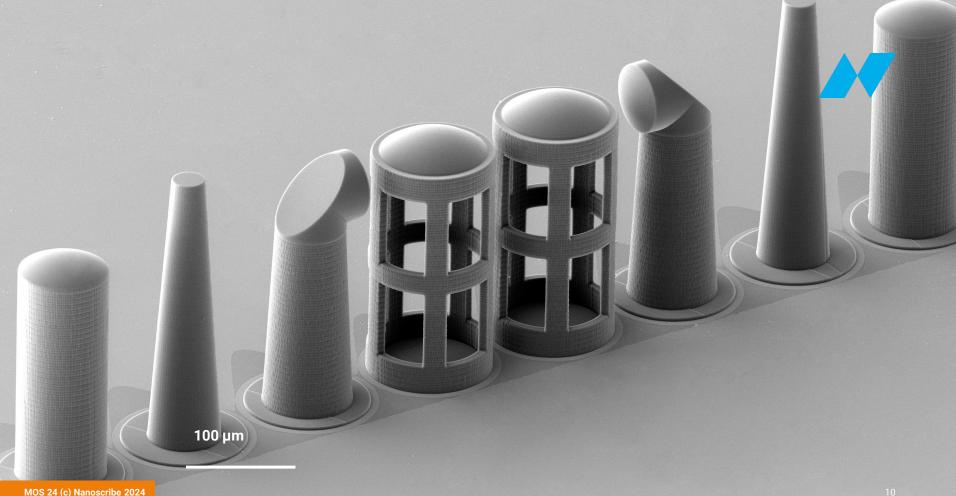
Microoptical elements on optical facet of fibers

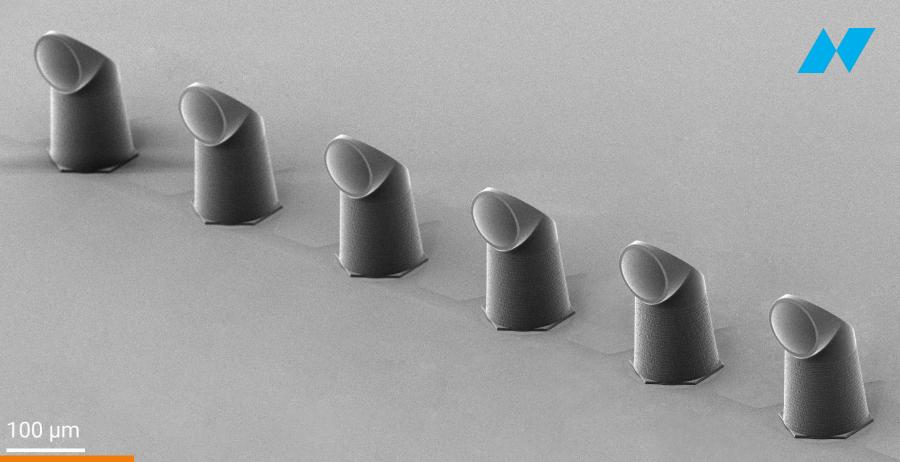


6µm MFD focus periscopic lens for 1550 nm with a polynomial TIR mirror

- down to 0.3dB loss per coupling interface for coupling two channels to each other
- Excess loss < 0.3 dB after 1000 h 85% humidity 85°C

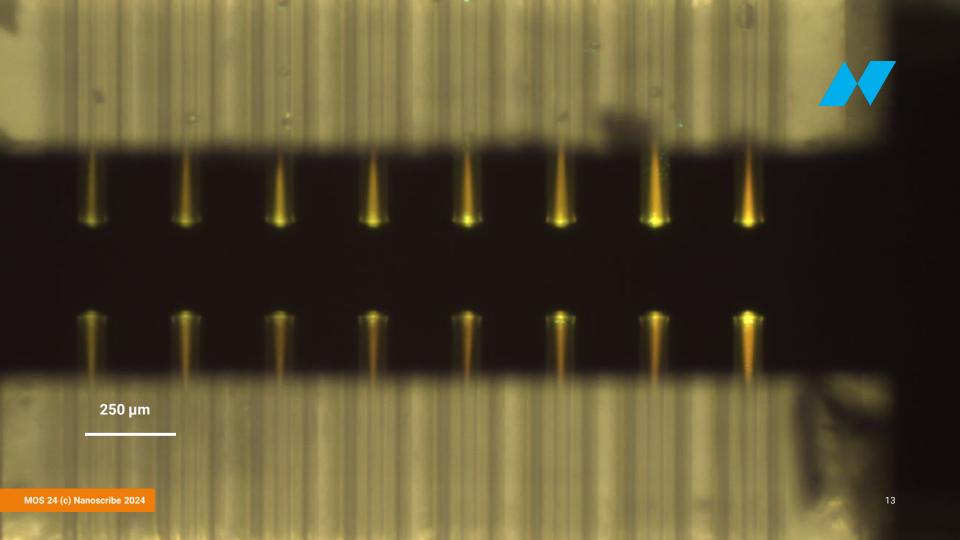






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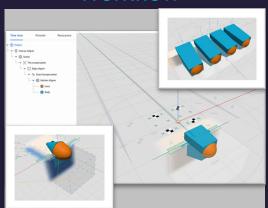


Microoptics on the Edgeof a Chip

Shapingthe beamfrom elliptical to round with low losses

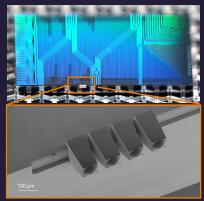


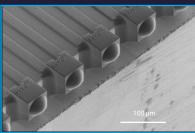
Workflow



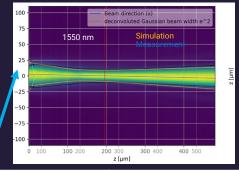
- Define lenses via formula or STL
- Align relative to fiducial and edge
- Select process parameters
- Print & develop

Results



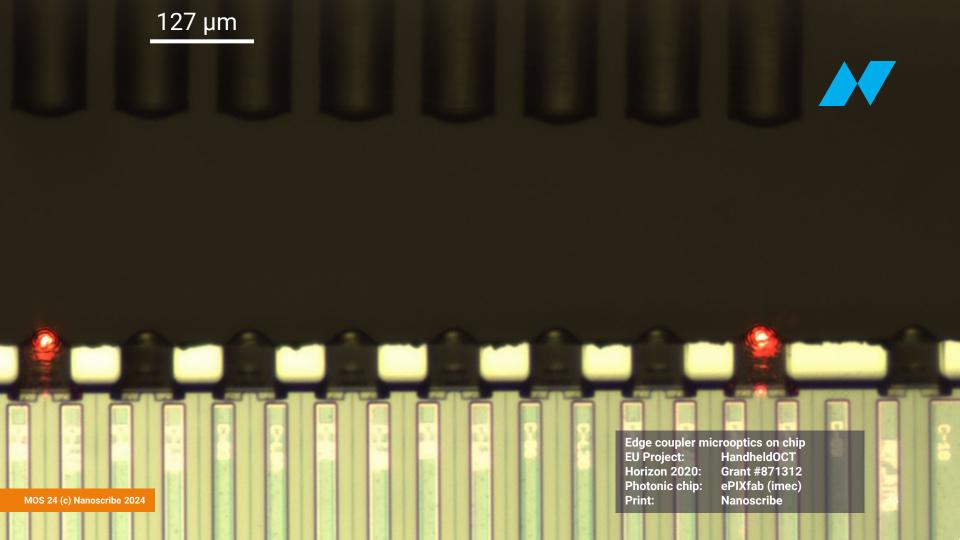


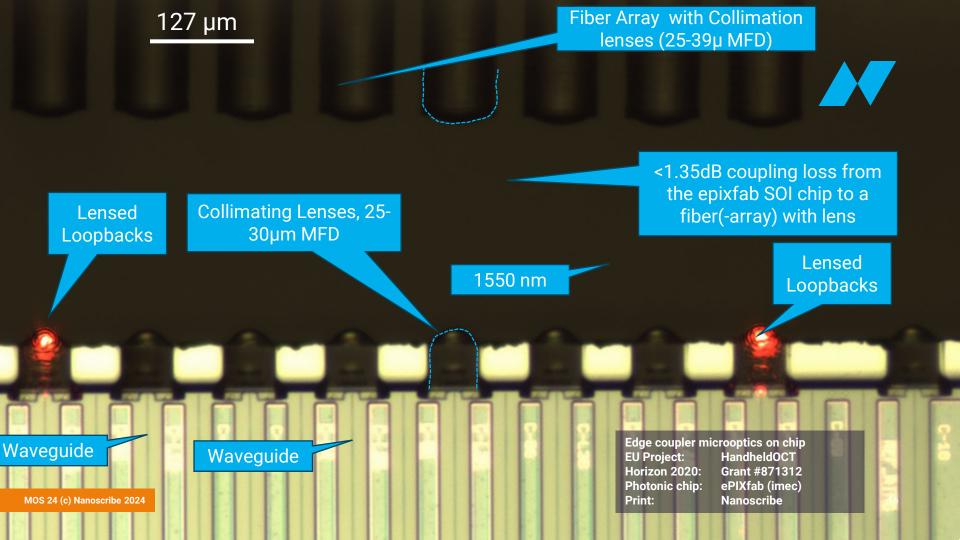
Characterization

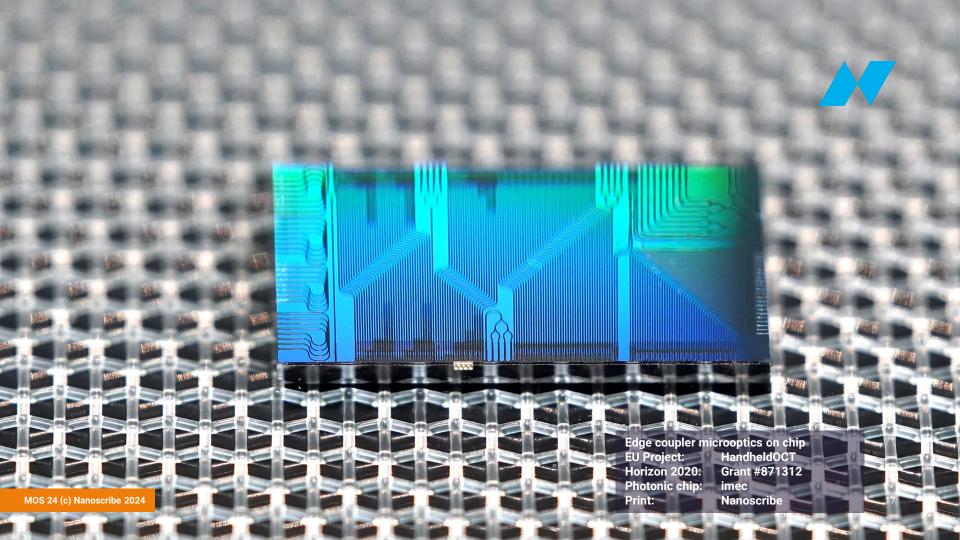


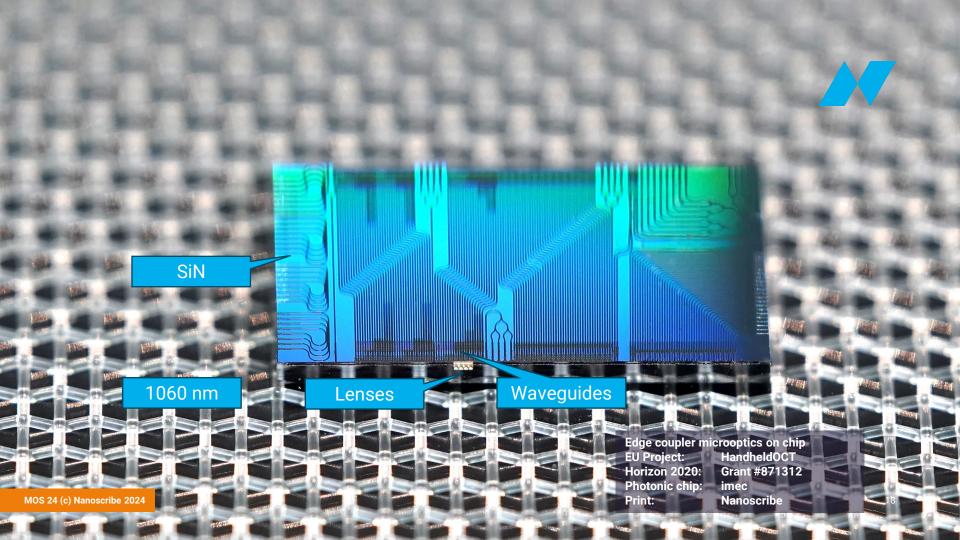
Characteristic	Typ. Value
Shape accuracy	+- 200 nm rms
Surface roughness R _a	<5 nm
MFD repeatability	σ < 40 nm
Loss	0.8 - 1.4 dB
Print time	90 - 280 sec
Environmental (Resin)	Thermal shock -25°C to 85°C (1,000 cycles); 85° C @ 85 % rh, 1000h

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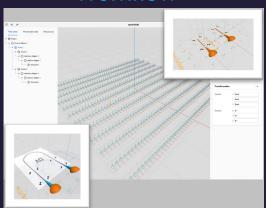
Vertical Coupling on Chip

Flexible designenabling low loss (broadband) coupling



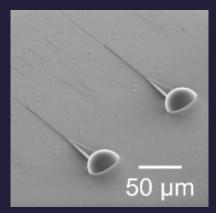


Workflow

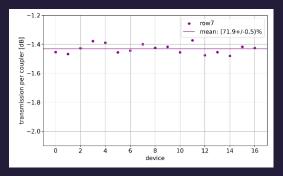


- Define lenses via STL and create array automatically
- Align relative to marker (<100 nm)
- Select process parameters
- Print & develop

Results

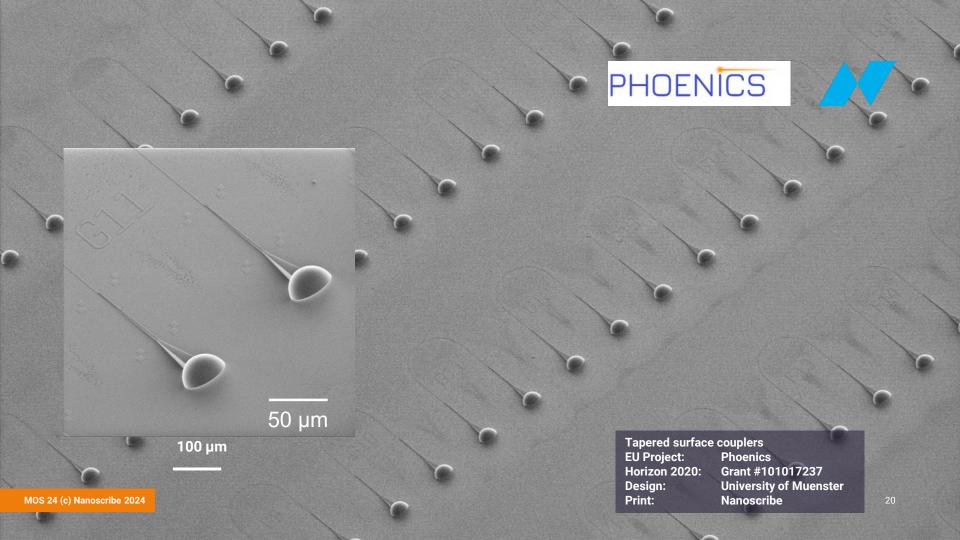


Characterization



Characteristic	Typ. Value
Shape accuracy	+-200nm rms
Surface roughness R _a	< 5 nm
MFD repeatability	σ < 40 nm
Loss	<1.5 dB
Print time	<60 sec
Environmental	Thermal Shock -25°C to 85°C (1,000 cycles); 85°C @ 85% rh 1000h; cryo at <3 K

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PHOENICS

Tapered TIR mirror with lens

SiN Die

Tapered surface couplers EU Project: Phoenics

Horizon 2020: Grant #101017237
Design: University of Muenster

Print: Nanoscribe

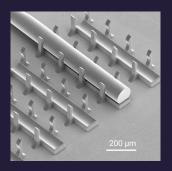
50 µm

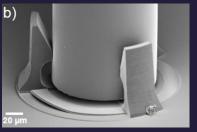
100 µm

3D Printed Optical Interconnects

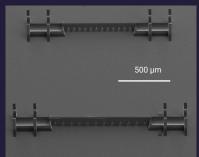
Mechano-optical fiber coupling schemes

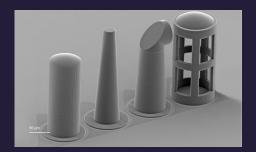


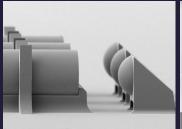


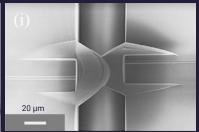


A. Bogucki al., Optics Express 11513 (2018)

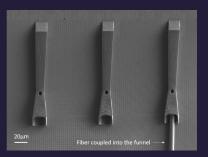


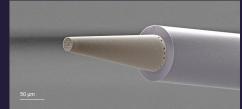






H. Huang et al., Light: Adv. Manuf. 5, 46 (2024)





J. Van Erps et al., J. Lightwave Technol. 38 (2020)

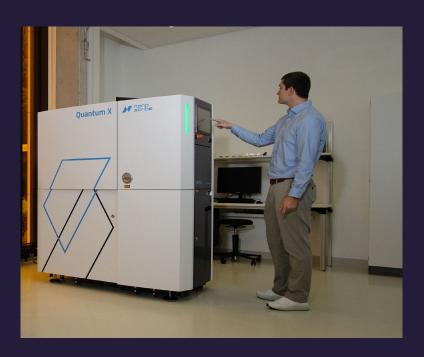
A. Gordillo, et al. Optics Express 27.15 (2019)

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Ouroffer: Quantum Xalign Connectto the photonic world





- 3D printing by 2GL® for optical quality at unrivaled speed*
 - Surface roughness R_a down to ≤5 nm
 - Shape accuracy S_a down to ≤200 nm
 - Process. time: 6 min / 8x lensed fiber array (typ)
 - 8" wafer processing
- Automatic alignment to predefined structures
 - On chips*: down to <100 nm detection accuracy of fiducials and chip edges
 - On fibers*: down to <500 nm detection accuracy of fiber cores
- Compatible with cleanrooms down to ISO 4

Ouroffer: Quantum Xalign We cover the whole process chain



Software



- Easy definition of print objects (lens formula, STL, OBJ)
- Align relative to each other or to fiber cores, fiducials, chip edges
- Remote control of printer

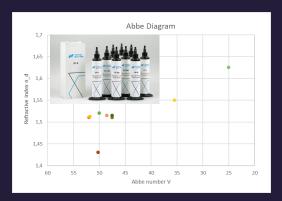
Hardware



- Detection modules for fiber cores and fiducials, chip edges
- Substrate holders for fibers, chips, wafers

Image: courtesy of PHIX

Printing materials

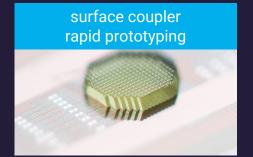


- High transparency
- High shape accuracy
- Smooth surfaces
- Different refractive indices
- Reliability data available

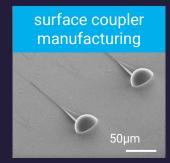
3D printed free-form microoptics by 2GL® *

Prototyping, Mastering & Scale Manufacturing



















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Web: nanoscribe.com

Thankyou for your attention!

As the pioneer in 3D printing solutions for optics and photonics, we push the limits of photonics packaging We deliver smart solutions to optical coupling challenges for best-in-class optical engineering and industrially mature innovations.

Validate our aligned 3D Microfabrication technology Get to know Quantum X align

- ▶ Schedule an online / on-site demo
- ▶ Check the feasibility of your project

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ISO 9001

Quality Management Systems

CERTIFIED

ISO 14001
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